

UNITED STATES DISTRICT COURT  
EASTERN DISTRICT OF NEW YORK

STMICROELECTRONICS N.V.,

*Plaintiff,*

v.

CREDIT SUISSE GROUP,

*Defendant.*

08-cv-3201 (RJD) (RML)

**MOTION FOR LEAVE TO  
LEAVE TO WITHDRAW  
ELISABETH GENN AS  
COUNSEL FOR  
STMICROELECTRONICS N.V.**

PURSUANT TO RULE 1.4 of the Local Rules of the United States District Courts for the Southern and Eastern Districts of New York, I, Elisabeth Genn, file this Motion for Leave to Withdraw my appearance as counsel for Plaintiff STMicroelectronics N.V. ("ST") in the above-captioned case. In support of this motion, I state as follows:

1. I, Elisabeth Genn, am identified as counsel to be noticed. As of April 29, 2011, I will be taking a leave of absence from Jenner & Block LLP.
2. ST remains represented by the law firm of Jenner & Block LLP and other attorneys from Jenner & Block LLP have entered appearances on behalf of ST in the above-captioned case.
3. The withdrawal of my appearance would not affect the case schedule in any way.
4. For the foregoing reasons, I respectfully request that this Court grant leave of my withdrawal as counsel for ST.

Dated: April 29, 2011

  
Elisabeth Genn

s/ Judge Raymond J. Dearie



So Ordered. 5/4/11